Laser Acceleration toward 100 GeV - Experimental suggestions -

Kazuhisa Nakajima

KEK High Energy Accelerator Research Organization, Japan SJTU Shanghai Jiao-Tong University, China SIOM, CAS Shanghai Institute of Optics and Fine Mechanics, China

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Outline

- Worldwide experimental progress and energy scaling
- Design of LWFA toward 100 GeV
- Positron production and acceleration by laser
- Long plasma channel generation at kHz rep rate
- Plasma channel coupler for staging
- Design of 10 100 GeV beam diagnostics
- Resonant LWFA at kHz rep rate





Stability in self-injection is as high as laser stability

Laser: P = 20TW 42fs FWHM, Intensity: 1.7×10^{18} W/cm² (a_0 =0.89), n_e =7.8x10¹⁸ cm⁻³



A steady-state-flow gas-fill capillary experiment at MPQ, Germany



J. Osterhoff et al., PRL 101, 085002 (2008)

1 cm gas jet experiment at GIST-APRI, Korea

Mean laser power 37TW, 35fs SD/Mean pulse energy = 4.6% $n_e^{\sim} 7 \times 10^{18} \text{cm}^{-3}$

Mean electron energy = 236.9 MeV SD/Mean E = 5 %; Charge: ~100pC Divergence angle: ~a few mrad

N. Hafz et al., nature photonics, 2, 571, 2008

Colliding injection controls energy and its spread with stability as high as laser

J. Faure et al., Nature 444, 737, 2006 Colliding injection experiment at LOA, France







Setup with side-laser triggering ablative capillary driven by PW laser



What is the optimum plasma density?

The electron plasma frequency:

$$\omega_p = \sqrt{\frac{4\pi e^2 n_0}{m_e}} = \frac{2\pi a}{\lambda_p}$$

- Plasma electron density n_0 corresponds to frequency of RF cavity, which characterizes accelerator performance .
- Minimizing the overall length of LPA linac $L_{c}=1 \text{ m}$ 400 main linac length (m) L = 2 m $L_{total} = \left[L_{stage} + L_c \right] \frac{E_b}{W}$ 300 200 E_{h} : the final beam energy W_{stage} : the energy gain in a single stage 100 L_{stage} : the single stage plasma length 0 L_c : the required coupling distance 0.05 0.1 0.5 5 10 $W_{stage} \propto E_z L_d \propto n_0^{-1} \quad L_{stage} \approx L_{nd} \propto n_0^{-3/2}$ plasma density, n (1017 cm-3) C. B. Schroeder et al., PRST-AB 13, 101301 (2010) For $E_b = 0.5$ TeV, $a_0 = 1.5$, The required operation plasma density $\approx 10^{17}$ cm⁻³ coupling distance $L_c \lesssim 1$ m Selection of • With minimization condition $L_c \sim L_{stage} \approx L_{pd}$ plasma density $L_{total} \propto L_{pd} N_{stage} \propto n_0^{-1/2}$ is not a big issue. • Plasma density is continuously tunable over the broad range. Plasma accelerator structure is not so expensive.

Plasma density could be determined by beam quality and power requirement

Radiation damping effect

Electrons accelerated by LPA undergo betatron oscillations due to strong focusing force
Emission of synchrotron radiation results in a energy loss and radiation damping with its rate.

$$P_{x} \approx \frac{2e^{2}\gamma^{2}}{3m^{2}c^{3}}F_{\perp}^{2} \qquad v_{\gamma} = \frac{P_{s}}{\gamma mc^{2}} = \frac{\tau_{R}\gamma}{m^{2}c^{2}}F_{\perp}^{2}$$
where $\tau_{R} = 2r_{e}/3c \approx 6.26 \times 10^{-24} \text{ s}$
 $r_{e} = e^{2}/mc^{2} = 2.818 \times 10^{-13} \text{ cm}$

$$F_{\perp} = -mc^{2}K^{2}x \qquad \text{for the linear regime}$$
 $K^{2} = 2x_{c}^{-2}(e\phi_{0}/mc^{2}) \qquad \text{for the linear regime}$
 $K = k_{p}/\sqrt{2}$
for the blowout (or bubble) regime

Power requirement for the linear collider

 $P_{h} = f N E \propto n_0^{1/2}$

 $P_{avg} \cong f U_L \sim f \cdot P_L \tau_L$

 $\propto n_0 \cdot n_0^{-1} \cdot n_0^{-1/2} \propto n_0^{-1/2}$

- Collision frequency: $f \propto N^{-2} \propto n_0$ for a constant required luminosity
- Beam power:
- Average laser power per stage:
- Total wall plug power $P_{wall} \propto N_{stage} P_{avg} \propto n_0^{1/2}$



P. Michel et al., PRE 74, 026501 (2006)

From points of high quality and power cost, choose plasma density of the order of 10^{16} cm⁻³



Design of 10 GeV acceleration stage
in the quasi-linear regime
$$a_0^2 \sim 1$$

1) Acceleration wakefield
For $k_p \sigma_z = 2/3$ σ_z :laser pulse duration
 $E_z [\text{GV/m}] \sim 0.3 \frac{a_0^2}{\sqrt{1 + a_0^2/2}} \sqrt{\frac{n_0}{10^{14} \text{ [cm}^{-3}]}}$
2) Acceleration length
Dephasing length: $L_d \approx \lambda_p \frac{\omega_0^2}{\omega_p^2} = \lambda_p \frac{n_c}{n_0}$
Pump depletion length:
 $k_p L_{pd} \approx \frac{8}{\sqrt{\pi}} \frac{\omega_0^2}{\omega_p^2} \frac{1}{a_0^2 k_p \sigma_z} \exp\left(\frac{k_p^2 \sigma_z^2}{2}\right) = \frac{8.5}{a_0^2} \frac{n_c}{n_0}$
3) Energy gain $\Delta W \approx eE_z L_{acc}$
 $\Delta W \approx eE_z L_{etch} \approx 0.2mc^2 \frac{a_0^2}{\sqrt{1 + a_0^2/2}} \frac{n_c}{n_0}$
 $\Delta W [\text{GeV}] \approx 0.18 \frac{a_0^2}{\sqrt{1 + a_0^2/2}} \left(\frac{10^{18} \text{ cm}^{-3}}{n_0}\right) \left(\frac{0.8 \mu \text{m}}{\lambda_0}\right)^2$

Design of 10 GeV electron injector in the weakly nonlinear regime $a_0 \ge 2$ For $k_p R \approx k_p r_L \approx 2\sqrt{a_0}$ R: Bubble radius r_L :laser spot radius $E_{z\max} \sim \sqrt{a_0} \frac{mc\omega_p}{e} \approx 96 [\text{GV/m}] \sqrt{\frac{a_0 n_0}{10^{18} \text{ cm}^{-3}}}$ **Dephasing length:** $k_p L_d \approx \frac{2}{3} \frac{\omega_0^2}{\omega_\perp^2} k_p R \approx \frac{4}{3} \sqrt{a_0} \frac{n_c}{n_0} \qquad L_d \approx \frac{2\sqrt{a_0}}{3\pi} \lambda_p \frac{n_c}{n_0}$ **Etching distance:** The laser etches back due to local pump depletion.
$$\begin{split} L_{etch} &\cong \frac{\omega_0^2}{\omega_p^2} c\tau_L = c\tau_L \frac{n_c}{n_0} \\ L_{etch} &\ge L_d \Longrightarrow c\tau_L \ge \frac{2}{3}R \approx \frac{2\sqrt{a_0}}{3\pi}\lambda_p \end{split}$$
 $\Delta W \approx e E_z L_d \approx \frac{4}{3} m c^2 a_0 \frac{n_c}{n_c}$ $\Delta W [\text{GeV}] \approx 1.2 a_0 \left(\frac{10^{18} \text{ cm}^{-3}}{n_0}\right) \left(\frac{0.8 \,\mu\text{m}}{\lambda_0}\right)^2$

The quasi-linear regime

4) Spot size

To avoid bubble formation

$$\frac{k_p^2 r_L^2}{4} \ge \frac{a^2}{\sqrt{1 + a^2/2}} \Longrightarrow k_p r_L \ge 2 \text{ for } a_0 \sim 1$$

To avoid self-focusing

$$\frac{P}{P_c} = \frac{k_p^2 r_L^2 a_0^2}{32} \le 1 \Longrightarrow k_p r_L \le 6 \text{ for } a_0 \sim 1$$

5) Power and energy requirement

$$P[TW] = \frac{a_0^2}{30} \left(\frac{r_L}{1\mu m}\right)^2 \left(\frac{0.8\mu m}{\lambda_0}\right)^2 \quad E_L[J] = P[TW]r_L[ps]$$

6) The maximum nunber of accelerated charge

For 100 % beam-loading efficiency with 100% energy spread,

$$N_{\max} \approx \left(\frac{n_{0}}{4\pi r_{e}}\right) \quad \frac{eE_{0}}{mc\omega_{p}}A \qquad A \approx \pi/k_{p}^{2}$$
$$\approx \frac{1}{32} \left(\frac{1}{r_{e}^{3}n_{0}}\right)^{1/2} \frac{a_{0}^{2}}{\sqrt{1+a_{0}^{2}/2}} k_{p}\sigma_{z} \exp\left(-\frac{k_{p}^{2}\sigma_{z}^{2}}{4}\right)$$
For $a_{0} = 1, k_{p}\sigma_{z} = 2/3$
$$N_{\max} \approx 6.6 \times 10^{9} \sqrt{\frac{10^{15}}{n_{0}[cm^{-3}]}} \qquad Q_{\max}[\text{nC}] \approx \sqrt{\frac{10^{15}}{n_{0}[cm^{-3}]}}$$

The weakly nonlinear regime

$$k_p R \approx k_p r_L \approx 2\sqrt{a_0} \Rightarrow r_L = \frac{\lambda_p}{\pi}\sqrt{a_0}$$

Ionization induced injection needs $a_0 \ge 2$ P/P 2.3 2.7 3.2 3.8 4.4 1.8 Measured Charge (Int counts) 10 elerated Simulated Charge 10 ectrons not observed P/P_~3 10 Self-injection threshold 8 105 Detection Limit 0.12.8 12 16 18 2 22 24 2.6 Initial Normalized Vector Potential (a,) $n_e \sim 1.4 \times 10^{19} \text{ cm}^{-3}$; He:N₂ 9:1 gas mix A. Pak et al., PRL 104.025003 (2010) $N_{\text{max}} \approx \frac{8}{15k_0r_e} \sqrt{\frac{e^2P}{m^2c^5}} \approx 2.5 \times 10^9 \frac{\lambda_0 [\mu\text{m}]}{0.8} \sqrt{\frac{P[\text{TW}]}{100}}$

7) Plasma channel

• Matched radius:

$$r_{M} = \left(\frac{r_{ch}^{2}}{\pi r_{e}\Delta n}\right)^{1/4} \qquad r_{e} = e^{2}/mc^{2}$$

• Channel depth:

$$\Delta n = \frac{r_{ch}^2}{\pi r_e r_M^4} \qquad \frac{\Delta n}{n_0} = \frac{4}{k_p^2 r_M^2} \left(\frac{r_{ch}}{r_M}\right)$$

• Critical channel depth:

$$\Delta n_c = \frac{1}{\pi r_e r_L^2} \qquad \frac{\Delta n_c}{n_0} = \frac{4}{k_p^2 r_L^2}$$

With $r_L = r_M \qquad \frac{\Delta n}{n_0} = \frac{4}{k_p^2 r_L^2} \left(\frac{r_{ch}}{r_L}\right)$

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• Critical channel depth:

$$\frac{\Delta n_c}{n_0} = \frac{4}{k_p^2 r_L^2} \approx \frac{1}{a_0}$$

Ablative capillary with r_{ch} =0.5 mm in the range of 10¹⁷ cm⁻³



Positron injector by ultraintense short laser pulse





Design of multi-stage LWFA toward 100 GeV

	Electron Injector	Positron Injector	10 GeV stage	100 GeV stage	Multi-stage 100 GeV	LBNL- BELLA 10 GeV
Energy gain ⊿W [GeV]	10	1.8	10	100	10 x 10	10
Laser intensity a_o	2.0	5.5	1.0	2.0	1.0	1.4
Spot radius <i>w_o</i> [μm]	31	10	64	80	64	90
Pulse duration $ au_{L}$ [fs]	68	20	120	216	120	95
Peak power <i>P</i> [TW}	130	100	137	865	10 x 137	563
Pulse energy <i>E_L</i> [J]	9	2	16	187	10 x 16	53
Plasma density n _e [cm ⁻³]	2.4 x 10 ¹⁷	5 x 10 ¹⁹	2.8 x 10 ¹⁶	2.4 x 10 ¹⁶	2.8 x 10 ¹⁶	1.0x10 ¹⁷
Plasma length L_p [cm]	15	0.1	200	470	10 x 200	~100
Maximum charge Q [nC]	0.46	1	0.2	2		0.3

*Stage energy gain of 10-100 GeV would be necessary for 1 – 10 TeV collider application

Comparison with 3D PIC simulation in the weakly nonlinear regime

000\$000\$000\$000000 40 **3D PIC simulation:** 30 $a_0 = 2, n_0 = 2.2 \times 10^{16} \,\mathrm{cm}^{-3}$ Energy (GeV) $\Rightarrow \overline{E}_{z} = 10 \, \text{GV/m}$ 20 C (GV cm⁻ $\Delta W \approx 20 \,\text{GeV} \,\text{in} \,L_{acc} = 2 \,\text{m}$ 10 2,000 4,000 6,000 x, boost (µm) Design: 2 5 Distance (m) $a_0 = 1, n_0 = 2.8 \times 10^{16} \,\mathrm{cm}^{-3}$ P = 1.4 PW, $a_0 = 2.0$, $\tau_1 = 160 fs$, $w_0 = 100 \mu m$ $n_{p} = 2.2 \times 10^{16} \text{ cm}^{-3}$, $L_{acc} = 528 \text{ cm}^{-3}$ $\Rightarrow \overline{E}_{z} = 5 \,\mathrm{GV/m}$ $\Delta W \approx 10 \,\text{GeV} \,\text{in} \,L_{acc} = 2 \,\text{m}$ Accelerating Plasma channel lectron beam Laser pulse

S. F. Martins et al., Nature Phys. 6, 311 (2010)



Preliminary test of a long-range plasma channel generated by RF discharge





Curved plasma channel coupler

A.J.W. Reitsma et al., POP 14, 053104 (2007) A. Reitsma, LPAW2007

Plasma density:

$$n(r) = n_0 (1 + r^2 / r_c^2)$$

Paraxial approximation:



Curved plasma channel







Synchronization of two laser pulses will be controlled by frequency domain interferometry with fs resolution

Two pulses split in the time interval *T* can be observed as fringes in the frequency domain interferogram. $E_{tot}(t) = E_1(t) + E_2(t - T)$

The power spectrum:



Synchronization $T \rightarrow 0$







Imaging Spectrometer





150MW average power laser for LWFA collider



Pulse Train Resonant Laser-Plasma Accelerator

Resonant LPA scheme mitigates requirement of a single ultra-intense laser pulse



Summary

- GeV-range high-quality, controllable and stable electron injectors are available in the state-of-art LPA technology.
- ➤ 100 GeV high-quality e⁻/e⁺ LPA experiment will be carried out with the multi-staging of LWFA operated in the linear regime at plasma density in the order of 10⁻¹⁶ cm⁻³ as well as the e⁻/e⁺ injector in the nonlinear regime.
- Meter-scale Long plasma channels necessary for staging will be generated with RF discharge at kHz-rep rate.
- Curved plasma channel will be used for coupling drive laser pulse in/out the stage at kHz-rep rate.
- Synchronization of stage-to-stage laser pulses will be adjusted by the frequency domain interferometry with fs resolution.
- > 10-100 GeV high-resolution spectrometer should be developed.
- RLPA may be useful for future fiber laser-based LWFA operated at kHz-rep rate.
- LPA community is ready for 100 GeV acceleration and kHz-LWFA with required lasers such as APOLLON and kHz-TW fiber lasers.